

Electronic Patent Application Fee Transmittal

Application Number:	10660813			
Filing Date:	12-Sep-2003			
Title of Invention:	Reactive ion etching for semiconductor device feature topography modification			
First Named Inventor/Applicant Name:	Hemant P. Mungekar			
Filer:	Patrick Maurice Boucher/Nina L. McNeill			
Attorney Docket Number:	A8067/T51700			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Petition-revive unintent. abandoned appl	1453	1	1500	1500
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				1500